EMC 01-0650(3003)
PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of John Davis Holder

Serial No. 10/002,862 Filed November 15, 2001

Confirmation No. 4783

For Intermittent Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon

Group Art Unit 1765

March 28, 2002

Office of Initial Patent Examination Customer Service Center Assistant Commissioner for Patents Washington, D.C. 20231



Sir:

We have received the updated filing receipt in the above-referenced U.S. patent application.

The filing receipt still shows the title as <u>Inermittent</u> Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon; whereas the correct information is <u>Intermittent</u> Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon.

A marked up copy of the filing receipt is attached. Please send us a corrected filing receipt.

Respectfully submitted,

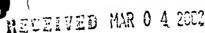
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APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY.DOCKET.NO | DRAWINGS | TOT CLAIMS | IND CLAIMS | 10/002,862 / 11/15/2001 / 1765 / 2490 | MEMC 01- 0650 (3003) / 4 / 96 6

000321 SENNIGER POWERS LEAVITT AND ROEDEL ONE METROPOLITAN SQUARE 16TH FLOOR ST LOUIS, MO 63102



CONFIRMATION NO. 4783 / UPDATED FILING RECEIPT
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Date Mailed: 02/21/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

John Davis Holder, Lake St. Louis, MO;

**Assignment For Published Patent Application** 

MEMC Electronic Materials, Inc.;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 12/26/2001

Projected Publication Date: 05/15/2003

Non-Publication Request: No

Early Publication Request: No

**Title** 

Intermittent feeding technique for increasing the melting rate of polycrystalline silicon 'Intermittent

**Preliminary Class** 

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TO 1700